

REMARKS

The claims of parent application Serial No. 10/041,409 were subject to a requirement for restriction as set forth in the Action mailed March 25, 2002. In response to that requirement, Applicants elected Claims 1-32 for prosecution in said parent application. Non-elected method Claims 33-64 are presented for examination in this divisional application.

The accompanying text for the specification and claims has been presented in accordance with the guidelines set forth in the notice entitled "Pre-Grant Publication Helpful Hint" of September 12, 2001, authored by Deputy Commissioner for Patent Examination Policy Stephen G. Kunin. Specifically, the specification reflects changes identical to amendments presented and entered in the parent application.

Specifically, paragraph [0023] has been amended to read:

"The amorphous material layer may be an amorphous dielectric layer, and the amorphous dielectric layer may be an amorphous silicon nitride layer, an amorphous alumina layer or a silicon oxide layer (SiO₂)."

Action on the merits is solicited.

Respectfully submitted,

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PETITION and
DEPOSIT ACCOUNT CHARGE AUTHORIZATION

This document and any concurrently filed papers are believed to be timely. Should any extension of the term be required, applicant hereby petitions the Director for such extension and requests that any applicable petition fee be charged to Deposit Account No. 50-1645.

If fee payment is enclosed, this amount is believed to be correct. However, the Director is hereby authorized to charge any deficiency or credit any overpayment to Deposit Account No. 50-1645.

Any additional fee(s) necessary to effect the proper and timely filing of the accompanying-papers may also be charged to Deposit Account No. 50-1645.